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FACSIMILE COVER SHEET

To: Commissioner for Patents Technology Center 2800	Total Pages Sent: 12 (including cover sheet)
Facsimile Number: (571) 273-8300	Transmission Date: September 20, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Weis, <i>et al.</i>	Docket No.:	02P15178US/INTECH 3.0-079
Serial No:	10/774,827	Art Unit:	2822
Date Filed:	February 9, 2004	Examiner:	Michael M. Trinh
Title:	Line Mask Defined Active Areas for 8F2 DRAM Cells with Folded Bit Lines and Deep Trench Patterns		

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at (571) 273-8300 on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Request for Continued Examination (RCE) Transmittal (2 duplicate pages)
- Petition for Extension of Time (2 duplicate pages)
- Amendment Accompanying RCE (7 pages)

Respectfully submitted,

Kristin R. Hayes
Legal Assistant

Confirmation Respectfully Requested

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